

Abstracts

COM2 enhanced graded base SiGe technology for high speed applications (2002 Vol. I [MWSYM])

T. Ivanov, M. Carroll, S. Moinian, M. Mastrapasqua, A. Frei, A. Chen, C. King, A. Hamad, E. Martin, S. Shive, T. Esry, C. Lee, R. Johnson, T. Sorsch, K. Banoo, P. Smith and W. Cochran.

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The COM2 enhanced graded base SiGe modular BiCMOS technology has been developed. It is based on the COM2 digital CMOS process. The technology achieves peak $f_{\text{sub}} t = 100$ GHz, peak $f_{\text{sub max}} = 101$ GHz, peak $\beta_{\text{spl}} = 186$ and $BV_{\text{sub cex}} = 2.05$ V. An $f_{\text{sub}} t \cdot BV_{\text{sub cex}}$ product of 205 and good across wafer uniformity are demonstrated.

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